

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KOBAYASHI
Application No.: 10/563,302
Filed: 1/4/2006
Title: ELECTROSTATIC CHUCK FOR SUBSTRATE STAGE, ELECTRODE USED
FOR THE CHUCK, AND TREATING SYSTEM HAVING THE CHUCK AND
ELECTRODE
Art Unit: 2836 Exr.: T. MAI CONF. No.: 8395

SUPPLEMENTAL AMENDMENT
and
STATEMENT OF SUBSTANCE OF INTERVIEW

MS: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 8, 2010

Sir:

In supplement to the Amendment filed on September 23, 2010, and in accordance with telephone interviews conducted with Exr. Mai on October 20, 2010, November 1, 2010 and November 5, 2010, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims;

Remarks are included following the amendments.